



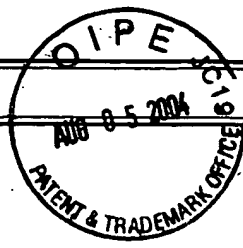
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Electronic Patent Application Submission
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EFS ID: 66051
Application ID: 10092231
Title of Invention: METHOD FOR MANUFACTURING
GALLIUM NITRIDE COMPOUND
SEMICONDUCTOR AND LIGHT
EMITTING ELEMENT
First Named Inventor: Shiro Sakai
Domestic/Foreign Application: Domestic Application
Filing Date: 2002-03-06
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Filing Type:
Confirmation number: 8663
Attorney Docket Number: 08228/021001



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Title of Invention

METHOD FOR MANUFACTURING GALLIUM NITRIDE COMPOUND
SEMICONDUCTOR AND LIGHT EMITTING ELEMENT

Application Number: 10/092231 
Date: 2002-03-06
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Submitted by:

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Jeffrey S. Bergman
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Documents being submitted

us-ids

Files

08228021001-usidst.xml

us-ids.dtd

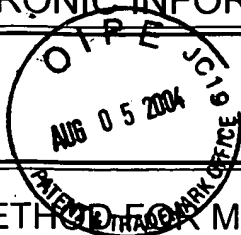
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Comments

IPDAS Version 3.4.4.0, Validation Version 1.1.1.2, Submission Version 1.2.0.0

ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18
 Stylesheet Version v18.0



Title of Invention

METHOD FOR MANUFACTURING GALLIUM NITRIDE COMPOUND
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Art Unit: 2815

Examiner: J. H. Nguyen

Search string: (5429954 or 5633192 or 5787104 or 6277665 or 5880485 or
 20040026704 or 20040051105).pn.

Certification: This Information Disclosure Statement was submitted under the following conditions, which satisfies the requirement under 37 CFR 1.97(e). The filer certified:

That no item of information contained in the information disclosure statement was cited in a communication from a foreign patent office in a counterpart foreign application, and, to the knowledge of the person signing the certification after making reasonable inquiry, no item of information contained in the information disclosure statement was known to any individual designated in 37 CFR 1.56(c) more than three months prior to the filing of the information disclosure statement.

US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
	AC**	5429954	1995-07-04	GERNER	B1		
	AD**	5633192	1997-05-27	MOUSTAKAS ET AL.			
	AE**	5787104	1998-07-28	KAMIYAMA ET AL.			
	AF**	6277665	2001-08-21	MA ET AL.			
	AG**	5880485	1999-03-09	MARX ET AL.			

US Published Applications

Note: Applicant is not required to submit a paper copy of cited US Published Applications

init	Cite.No.	Pub. No.	Date	Applicant	Kind	Class	Subclass

	AA**	20040026704	2004-02-12	NIKOLAEV ET AL.	A1
	AB**	20040051105	2004-03-18	TSUDA ET AL.	A1

Signature

Examiner Name	Date